



# Application of Near-Field thermal Radiation in Thermal Rectifiers

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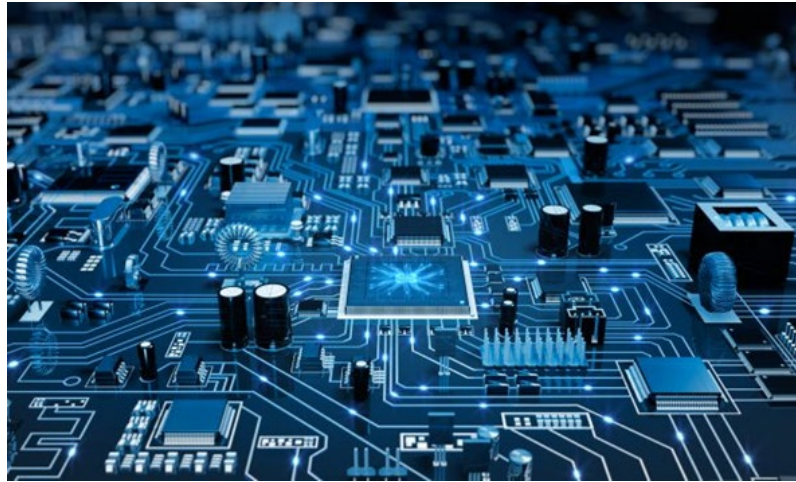
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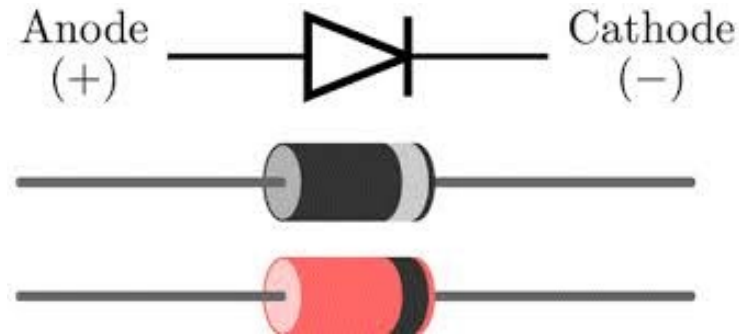
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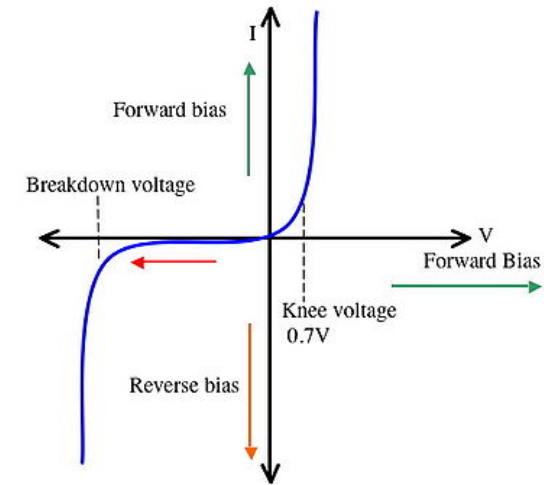
# Backgrounds



Electric technology



Electric Diode

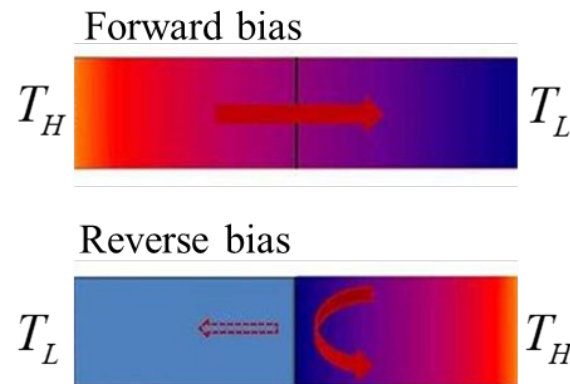


Rectification of electrons flow

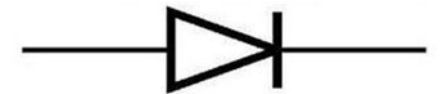
Controlling the heat flow may provide alternative ways to process information at harsh conditions



## Thermal Rectification

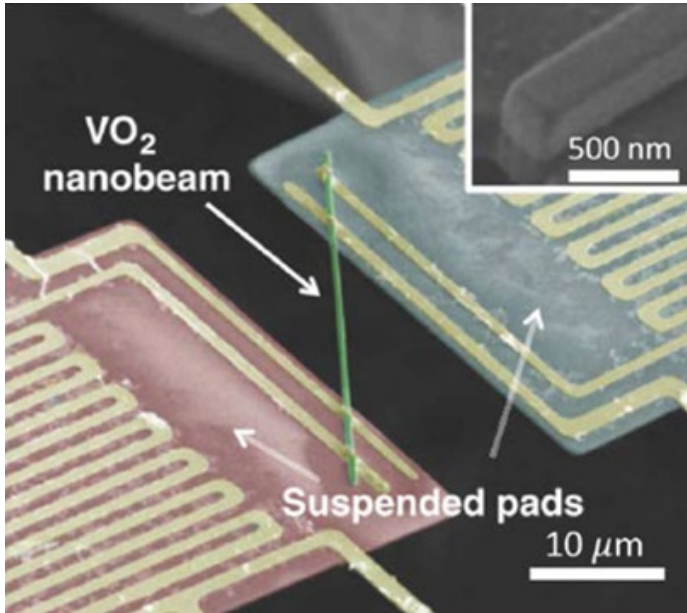


## Thermal Diode Thermal Rectifier



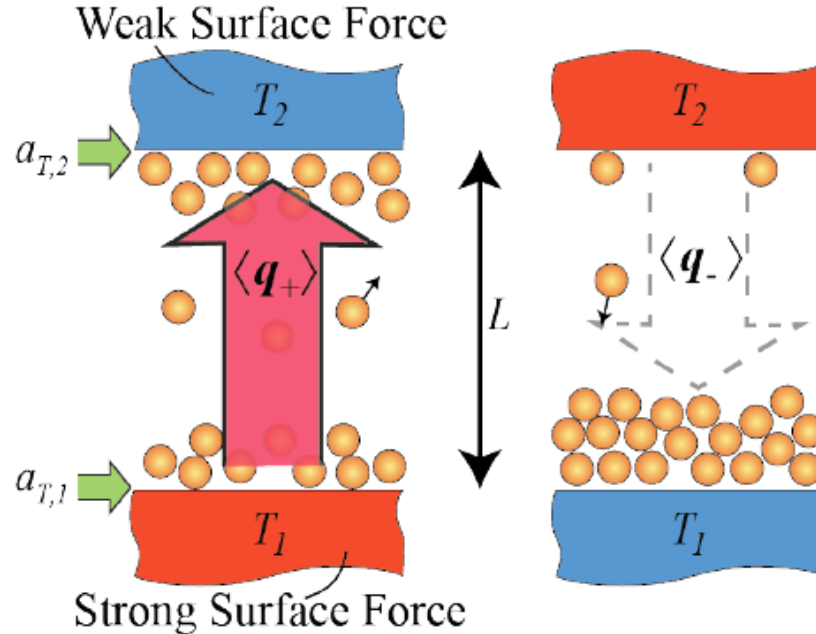
# Backgrounds

Heat flow can be realized by three approaches: **Conduction** | **Convection** | **Radiation**



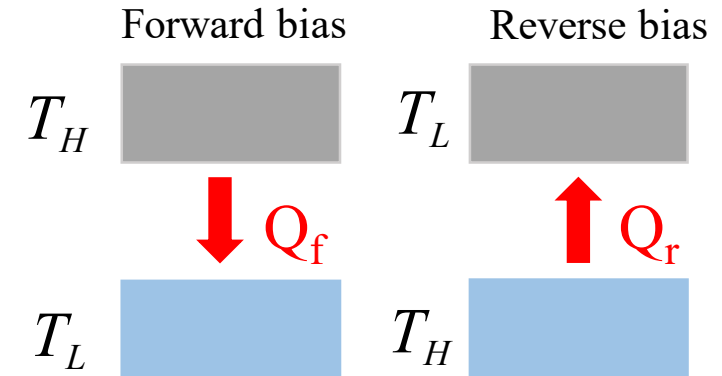
Conduction-based thermal rectifier

Chang et al. *Science* 2006, Vol. 314, 1121-1124



Convection-based thermal rectifier

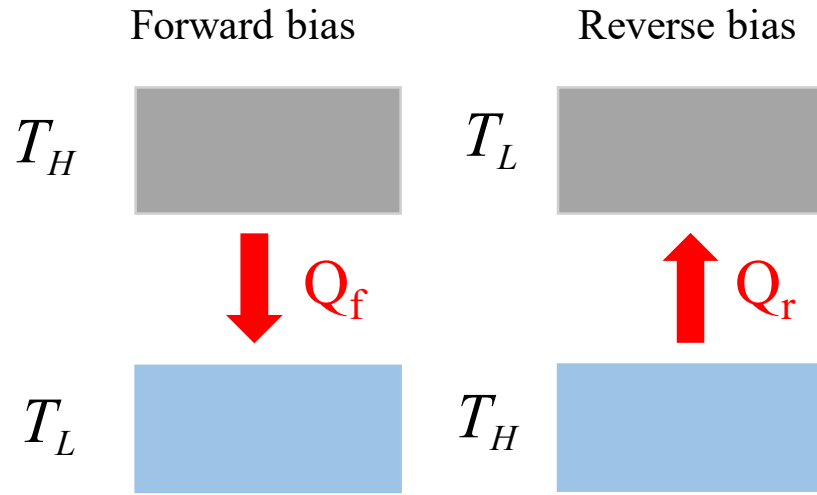
Avanessian and Hwang, *ICNMM2015* - 48508



Radiation-based thermal rectifier

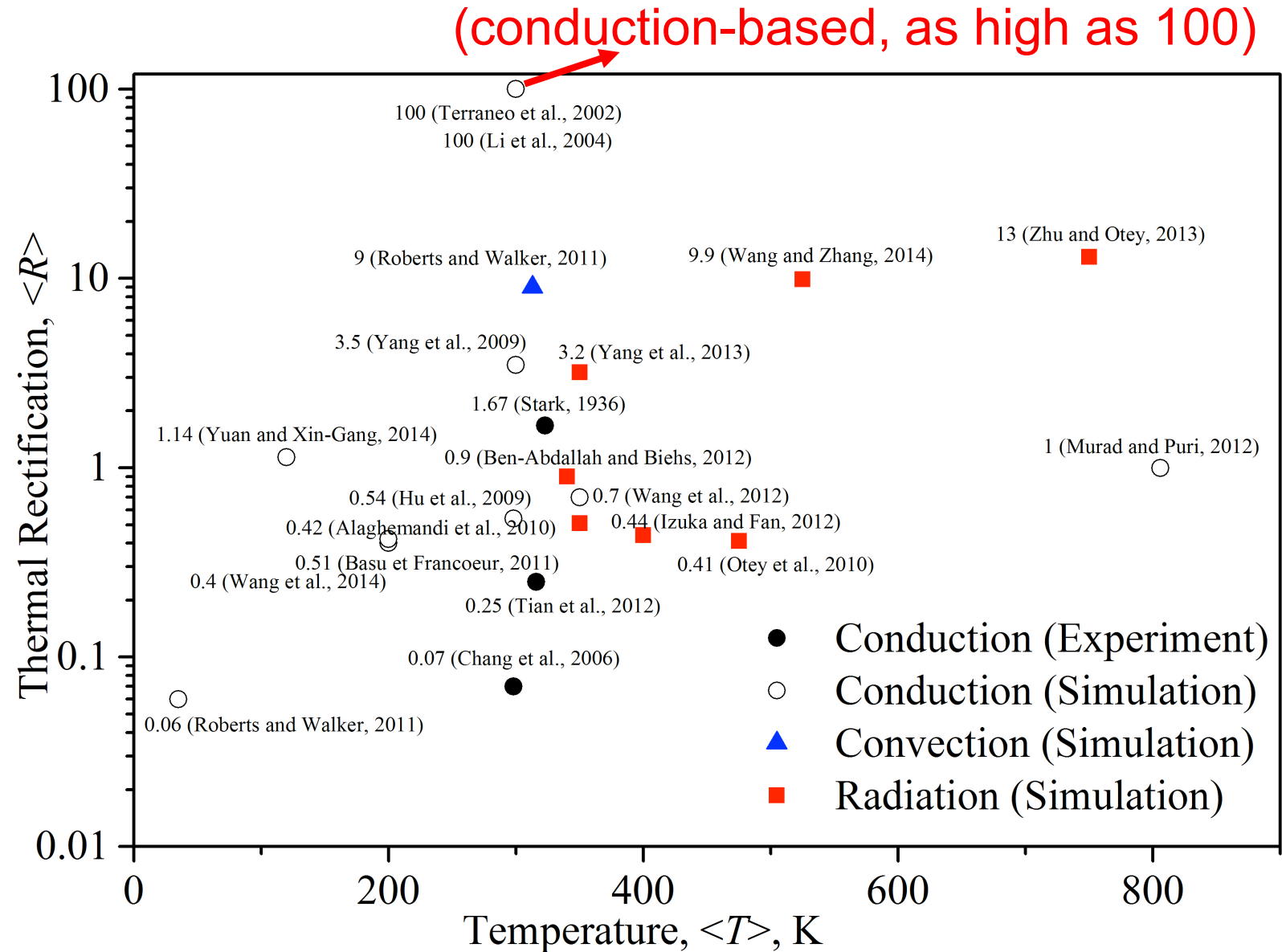
**Merits:** avoid contact and intrusion

# Problem



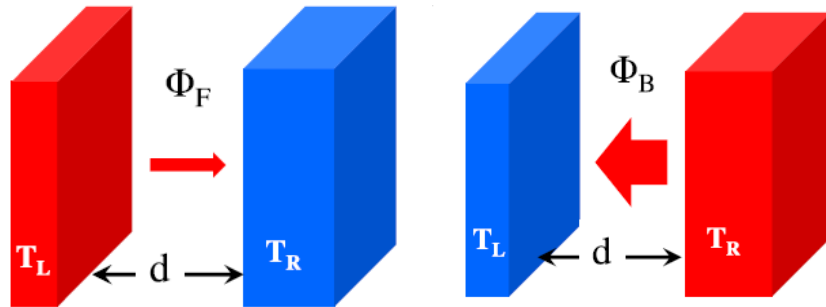
## Thermal rectification ratio:

$$R_{\text{ratio}} = \frac{Q_{\text{f}}}{Q_{\text{r}}} - 1$$



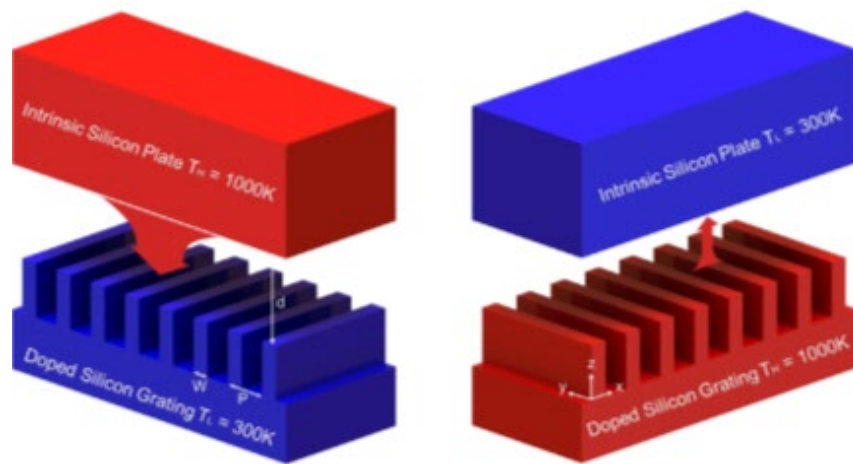
# Method

## Flat-plate



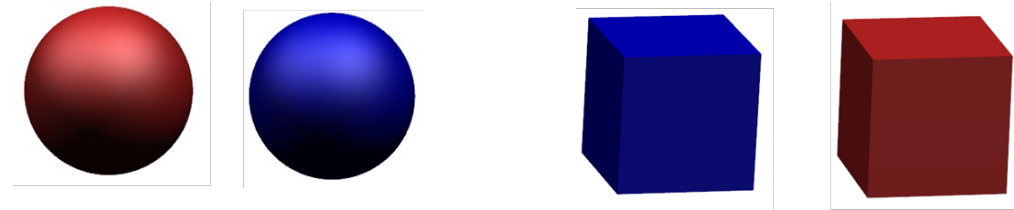
Ben-Abdallah et al. *AIP ADVANCES* 5, 053502 (2015)

## Plate with nanostructures



Shen et al. *JQSRT*, Vol. 211, 1-8 (2018)

## Nanoparticles-based rectifier in my work



Calculating Near-field thermal radiation:

**1. Two spheres:** spectral poynting vector  $E(r_1, \omega) \times H(r_1, \omega)$

$$\langle E_{i\omega}(r_1, \omega) H_{j\omega}^*(r_1, \omega) \rangle = i\omega\mu_0 \int_V d^3r' \left\{ \overline{\overline{G}}_E(r_1, r, \omega) \overline{\overline{G}}_H^*(r_1, r, \omega) \langle J_l(r, \omega) J_m^*(r', \omega) \rangle \right\}$$

$$\left. \begin{array}{l} \overline{\overline{G}}_E(r_1, r, \omega) \\ \overline{\overline{G}}_H(r_1, r, \omega) \end{array} \right\}$$

**Dyadic Green's functions (DGFs)**

are obtained by using partial-wave

**2. Nanoparticles with irregular shapes:**

**Thermal discrete dipole approximation method (TDDA):**

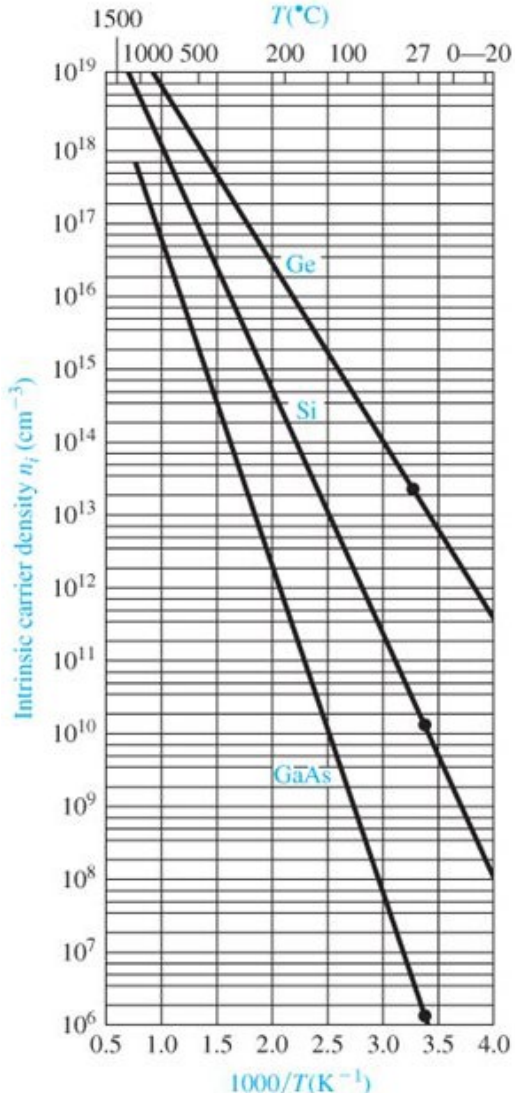
The emitter and absorber are discretized into electric dipoles with the number of  $N_e$  and  $N_a$

$$Q_\omega = \frac{\omega}{2} \sum_{i=N_e+1}^{N_e+N_a} \left( \text{Im} \left[ \left( \alpha_i^{-1} \right)^* \right] \frac{2}{3} k_0^2 \right) \text{tr} \left( \overline{\overline{R}}_{p_i p_i} \right)$$

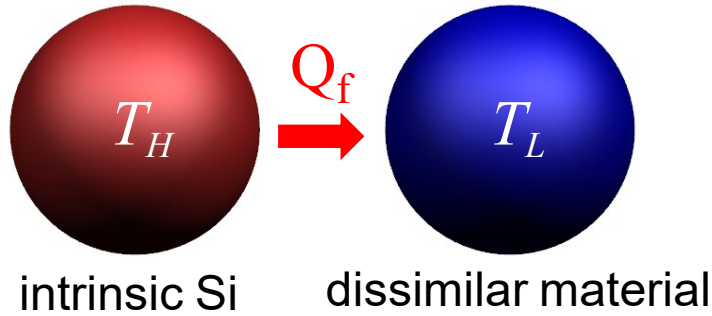


# Method

Electrons of silicon will be excited at high temperatures

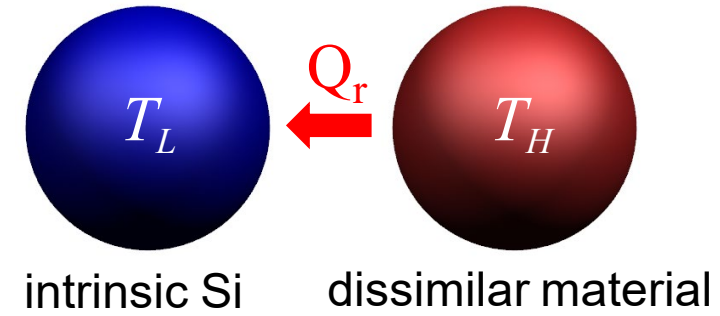


forward bias



Electrons will be excited at high temperatures, which gives rise to the enhancement of radiative heat transfer

reverse bias



Electrons won't be excited, which give rise to the constraint of radiative heat transfer

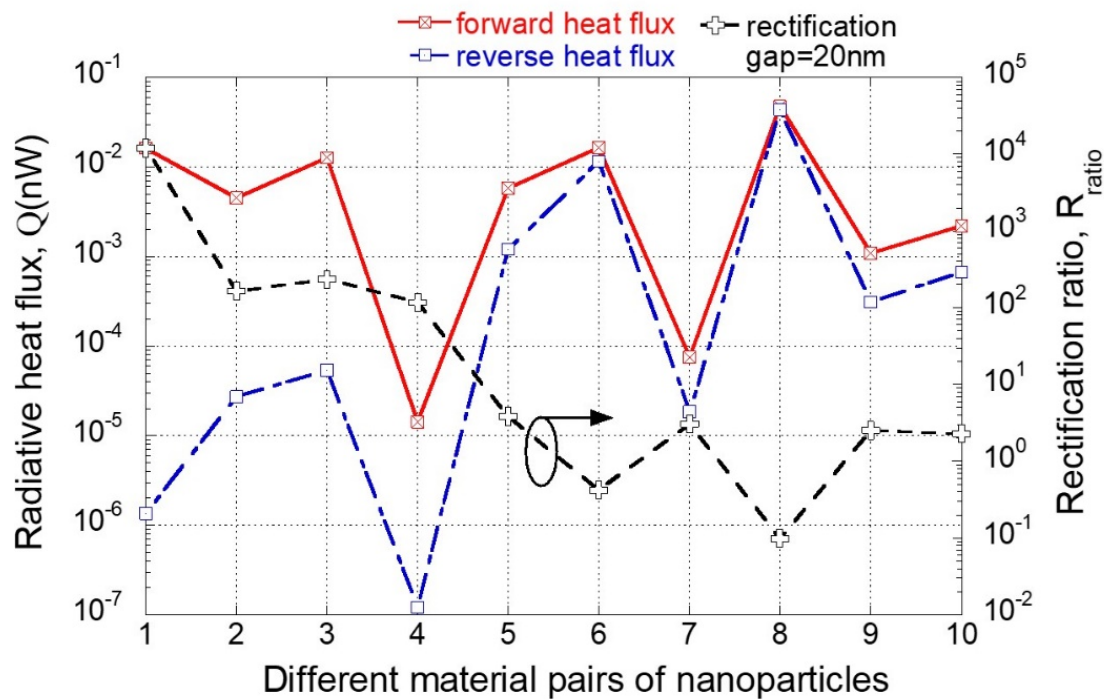
High rectification ratio

- The temperature-dependent dielectric function of silicon is obtained from Fu and Zhang.

Fu et al. *International Journal of Heat and Mass Transfer* **2006**, Vol. 49,1703-1718

# Results

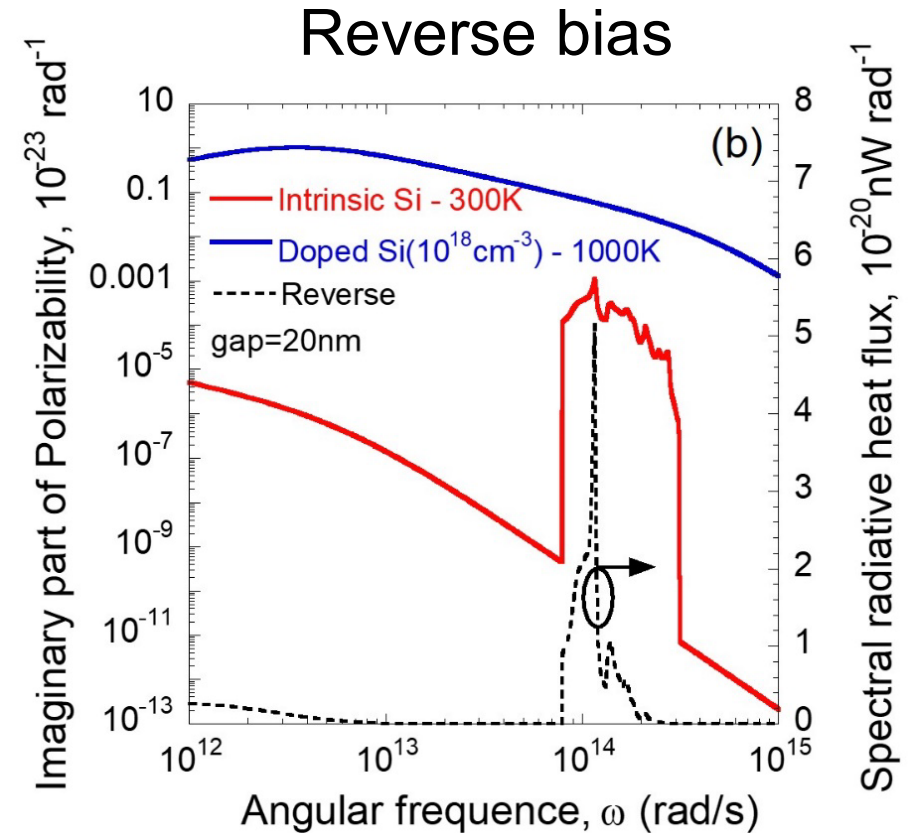
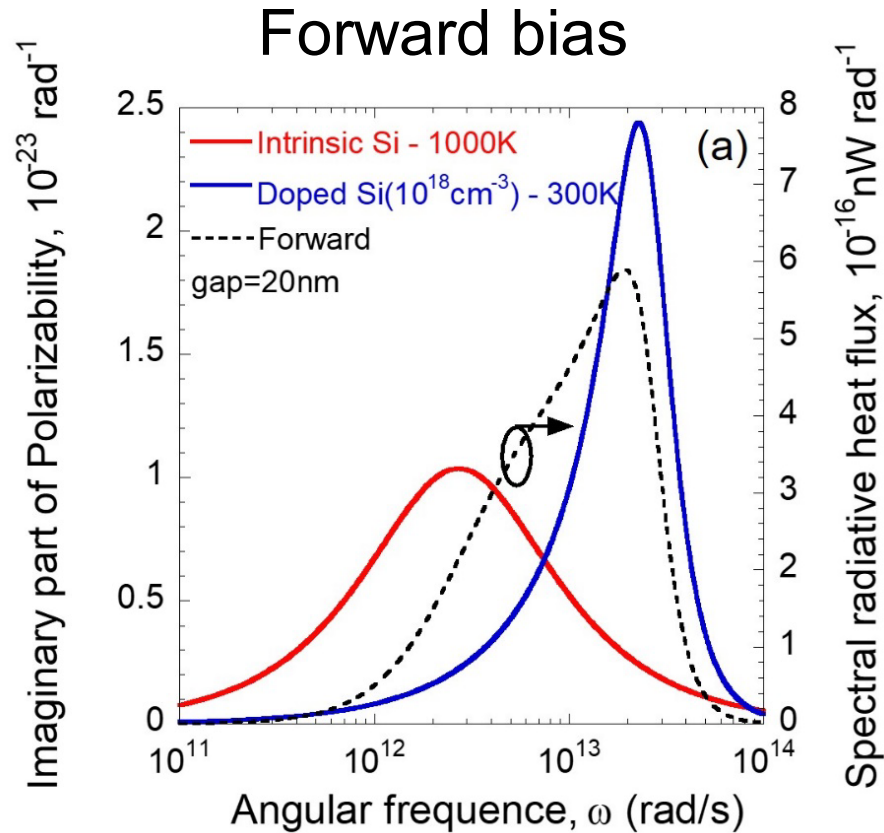
Numbers	Material Pairs	Numbers	Material Pairs
1	Intrinsic Si - Doped Si ( $10^{18} \text{ cm}^{-3}$ )	6	Doped Si( $10^{18} \text{ cm}^{-3}$ ) - $\text{SiO}_2$
2	Intrinsic Si - 3C-SiC	7	Doped Si( $10^{18} \text{ cm}^{-3}$ ) - Au
3	Intrinsic Si - $\text{SiO}_2$	8	3C-SiC - $\text{SiO}_2$
4	Intrinsic Si - Au	9	3C-SiC - Au
5	Doped Si( $10^{18} \text{ cm}^{-3}$ ) - 3C-SiC	10	$\text{SiO}_2$ - Au



Near-field radiative heat flux and rectification ratio of the proposed diode for different material pairs

- Rectification ratios are **all above 100** when intrinsic Si is included in the material pair (See number 1 2 3 4).
- Rectification ratios are less than 5 when intrinsic Si is not included in the material pair (See number 5 6 7 8 9 10).
- A **record-high** rectification ratio of **more than  $10^4$**  is theoretically achieved when the material pair is intrinsic Si and dope Si ( $10^{18} \text{ cm}^{-3}$ )

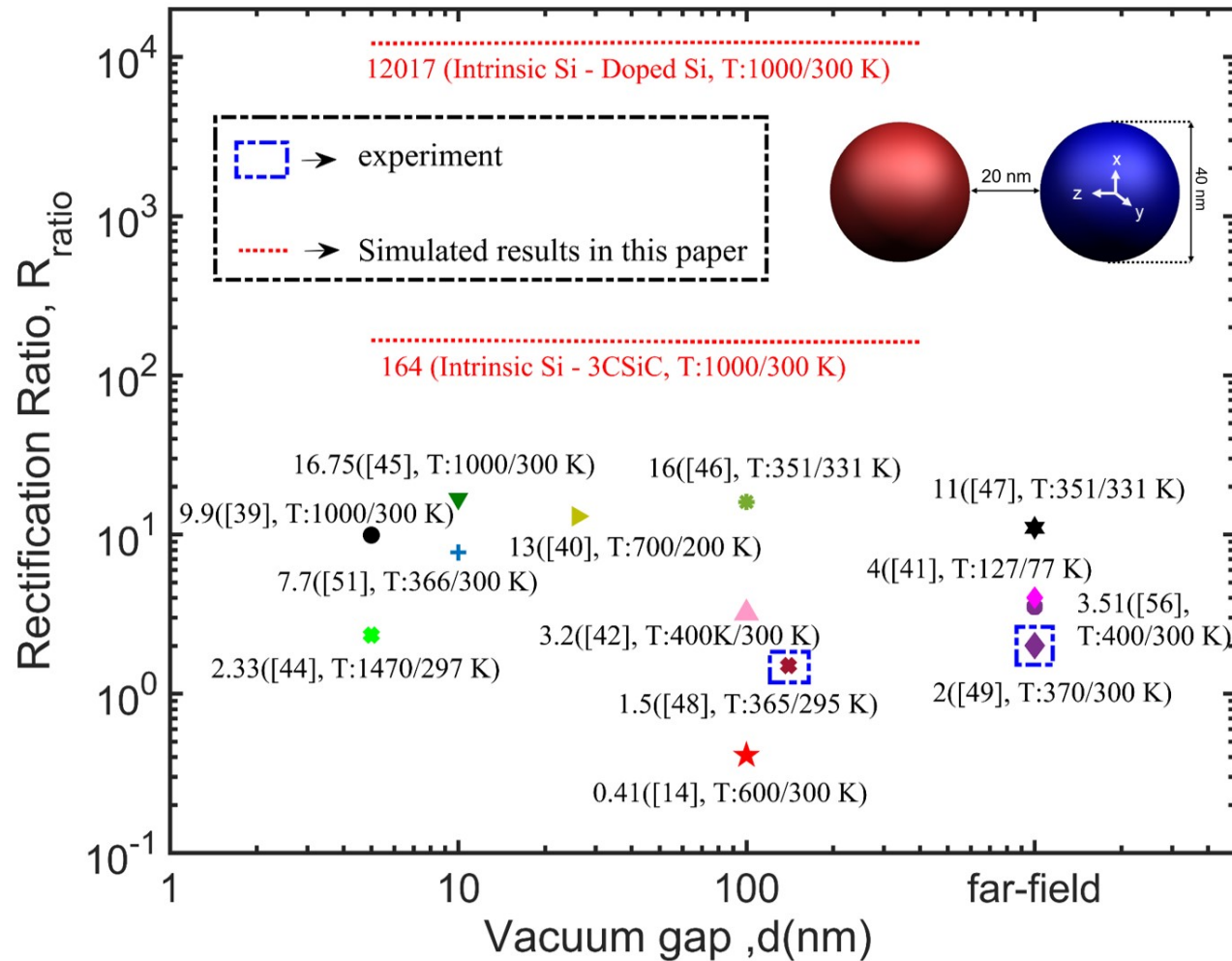
# Results



- In forward biased case, the carrier concentration of intrinsic Si at 1000 K will have nearly the same value as that in doped Si ( $10^{18} \text{ cm}^{-3}$ ) at 300 K. Polarizability of two material will have a strong match
- In the reverse biased case, polarizability for doped Si at 1000 K will merely match the peak induced by absorption of lattice vibration for intrinsic Si at 300 K.



# Conclusions



- A highly efficient radiative thermal rectifier consisting of two nanoparticles, i.e., intrinsic Si nanoparticle and a dissimilar nanoparticle, is proposed. Due to the thermal excitation of intrinsic Si at high temperature, rectification ratios can reach more than 100.
- Particularly, for the nanoparticles comprising by intrinsic Si and doped Si ( $10^{18} \text{ cm}^{-3}$ ), the rectification ratio can reach a record-high value of more than  $10^4$  due to the strong match of polarizability.
- Effects of gap distances and configurations of nanoparticles on the rectification ratio can be found in my paper.

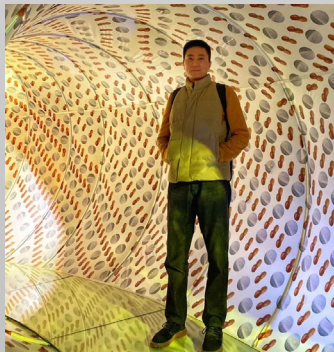
# Outline

Thank you for listening!

## Acknowledgement



Xianglei Liu



Jiadong Shen



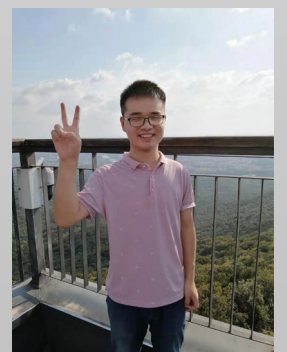
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